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**BOX AF**

AMENDMENT UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
GROUP 1733  
PATENT APPLICATION

IFW  
AF  
1733

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q68442

Tadahiro KEGASAWA, et al.

Appln. No.: 10/071,183

Group Art Unit: 1733

Confirmation No.: 2983

Examiner: Barbara J. MUSSER

Filed: February 11, 2002

For: RESIN FILM FORMING METHOD, AND LAMINATE PRODUCTION METHOD AND APPARATUS

**AMENDMENT UNDER 37 C.F.R. § 1.116**

**MAIL STOP AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated March 17, 2004, please amend the above-identified application as follows on the accompanying pages.

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